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	Application No.	Applicant(s)
Notice of Allowability	09/690,330	KIKKAWA ET AL.
	Examiner	Art Unit
	Thoi V Duong	2871
The MAILING DATE of this communication appears on the cover sheet with the correspondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308.		
1. This communication is responsive to <u>11/07/2003</u> .		
2. ☑ The allowed claim(s) is/are 12,15-17 and 19.		
3. The drawings filed on are accepted by the Examiner.		
<ul> <li>4.</li></ul>		
<ul> <li>Attachment(s)</li> <li>1. ☑ Notice of References Cited (PTO-892)</li> <li>2. ☑ Notice of Draftperson's Patent Drawing Review (PTO-948)</li> <li>3. ☑ Information Disclosure Statements (PTO-1449 or PTO/SB/O Paper No./Mail Date 0403</li> <li>4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material</li> </ul>	6. ☐ Interview Summ Paper No./Mail 08), 7. ⊠ Examiner's Ame	Date

### **DETAILED ACTION**

This office action is in response to the Amendment filed November 7, 2003.
 Accordingly, a verified English translation of Japanese Patent Application Serial No. 11-296002, which is Applicant's priority claim, has been received.

Currently, claims 12 and 15-19 are pending in this application. Claims 1-11, 13 and 14 were previously cancelled.

#### **EXAMINER'S AMENDMENT**

2. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with Norman P. Soloway (Reg. No. 24,315) on 03/02/2004.

## In the claims:

Claim 18: cancel claim 18.

Claim 15:

In line 10, after "substrate", delete ";" and insert --,--;

In line 13, after "substrate", delete "." and insert --; and--;

In new line 14, insert --wherein said light scattering mechanism comprises a flattened film formed to cover the uneven insulation film.--.

# Allowable Subject Matter

3. Claims 12, 15-17 and 19 are allowed.

Application/Control Number: 09/690,330

Art Unit: 2871

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The following is an examiner's statement of reasons for allowance: none of the prior art of record fairly suggests or shows all of the limitations as claimed. Specifically,

Re claims 12, 15, 16 and 19, none of the prior art of record discloses, in combination with other limitations as claimed, a light scattering mechanism comprising an uneven portion (or an uneven insulation film) formed on the surface of the liquid crystal side of the transparent insulation substrate and a flattened film (or a scattering auxiliary film, or a flattened and scattering auxiliary film) formed to cover the uneven portion.

The most relevant reference, JP 2000-066186, discloses a light scattering mechanism 21 comprising an uneven portion 2 and a flattened film 3 provided at the liquid crystal side surface of the opposite substrate 1 as shown in Fig. 1. However, this reference was published on March 3, 2000 after the filing date of Applicants' Priority, Japanese Application Serial No. 11-296002, filed October 18, 1999. A verified English translation of Applicants' Priority was submitted on November 17, 2003.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

#### Conclusion

4. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Thoi V. Duong whose telephone number is (571) 272-

Art Unit: 2871

2292. The examiner can normally be reached on Monday-Friday from 8:30 am to 4:30 pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Robert Kim, can be reached at (571) 272-2293.

Thoi Duong

03/04/2004

DUNGT. NGUYL...
PRIMARY EXAMINE